

ABSTRACT

METHOD OF MANUFACTURING A TRANSPARENT ELEMENT
INCLUDING TRANSPARENT ELECTRODES

Method of manufacturing a transparent element including transparent electrodes, said method including the steps of:

- depositing over at least one part of the surface of a transparent substrate (1)
- 5 a layer (2) of a conductive oxide that is also transparent, and
 - structuring in said conductive oxide layer (2) at least one electrode (4) connected to a contact pad (8) by a conductive path (6) by removing said oxide along the contour of the desired electrode (4, 6, 8) so as to create a trimming line (10) which will insulate the part (12) of the conductive oxide layer (2), which forms the electrode
 - 10 (4, 6, 8) and which is to be brought to an electric potential, from the rest (14) of the conductive oxide layer (2) which will be floating,
 - this method being characterized in that at least a second trimming line (10') is made around the first (10).

15

Figure 2